

PATENT  
ATTORNEY DOCKET NO.: 46884-5388 (211285)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Fumitsugu FUKUYO et al.	)	
	)	Confirmation No.: 4531
Application No.: 10/537,509	)	
	)	Group Art Unit: 2892
Filed: November 30, 2005	)	
	)	Examiner: Elias Ullah
For: METHOD FOR CUTTING	)	
SEMICONDUCTOR SUBSTRATE	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop RCE**  
Alexandria, VA 22314

Sir:

**AMENDMENT**

In response to the final Office Action dated May 12, 2009, and pursuant to 37 C.F.R. § 1.116, the period for response to which extends through November 12, 2009 with the concurrently filed Petition for a Three-Month Extension of Time, please amend the above-identified application as follows. A Request for Continued Examination (RCE) is being filed concurrently herewith.